

SAC 09/652,713

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Trung T. Doan

Examiner: Sylvia MacArthur

Serial No.: 09/652,713

Group Art Unit: 1763

Filed: August 31, 2000

Docket No.: 303.928US5

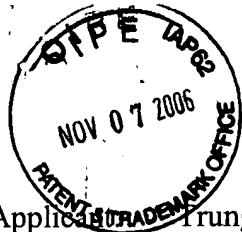
Title: CHEMICAL DISPENSING SYSTEM FOR SEMICONDUCTOR WAFER  
PROCESSING

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AMENDMENT AND RESPONSE UNDER 37 CFR § 1.111

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

This paper responds to the Office Action mailed on October 3, 2006. Please amend the above-identified patent application as follows.



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Title: CHEMICAL DISPENSING SYSTEM FOR SEMICONDUCTOR WAFER PROCESSING

Docket No.: 303.928USS

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Due Date: January 3, 2007

Examiner: Sylvia MacArthur

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**MS Amendment**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

We are transmitting herewith the following attached items (as indicated with an "X"):

Return postcard.  
 Amendment and Response (8 pgs.).

If not provided for in a separate paper filed herewith, Please consider this a PETITION FOR EXTENSION OF TIME for sufficient number of months to enter these papers and please charge any additional fees or credit overpayment to Deposit Account No. 19-0743.

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.

Customer Number 21186

By:   
Atty: Timothy B. Chase  
Reg. No. 40,957

CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to: MS Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this 2 day of November, 2006.

Name Kate Grunder

Signature Kate G

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.  
(GENERAL)